



IFW

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Makoto UEKI, et al.

Docket No: Q88465

Appln. No.: 10/538,306

Group Art Unit: 2811

Confirmation No.: 3461

Examiner: Ajay ARORA

Filed: June 9, 2005

For: COPPER ALLOY FOR WIRING, SEMICONDUCTOR DEVICE, METHOD FOR FORMING WIRING AND METHOD FOR MANUFACTURING SEMICONDUCTOR DEVICE

RESPONSE TO RESTRICTION REQUIREMENT

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

This responds to the Restriction Requirement, dated September 7, 2006. In response to the Restriction Requirement, Applicant elects Group II, claims 17-25 for examination. This election is made without traverse.

Applicant reserves the right to file a Divisional Application directed to non-elected claims 7-16.

Prompt and favorable action on the elected claims is now respectfully requested.

Respectfully submitted,


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WASHINGTON OFFICE

23373

CUSTOMER NUMBER

Date: September 28, 2006


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